

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Ayesha S. Wilks

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Dirk J. Sundt,

Attorney Docket No.: 501085.02

William A. Polinsky, Mark A. Bossler, Gabriel G. Videla and

Chris L. Inman

Serial No. : 10/620,782

Group Art Unit

: Not Yet Assigned

Filed

: July 15, 2003

Examiner

: Not Yet Assigned

Title

: STRUCTURE AND METHOD FOR FORMING A FACETED OPENING AND A

LAYER FILLING THEREIN

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 10/007,295, filed November 8, 2001. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in this prior application and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information

they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

I hereby certify that no item set forth on the attached form PTO-1449 was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge, after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Supplemental Information Disclosure Statement.

Please acknowledge receipt of this Supplemental Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,

DORSEY & WHITNEY LLP

Kimton N. Eng Registration No. 43,605

KNE:sem

Enclosures:

Postcard Form PTO-1449

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FORM PTO-144 (REV.7-80))	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			1		l	APPLICATION NO. 501085.02			
INF	ORM	ATION DISCLOSU	RE STATEM	IENT	APPLICANT(S) Dirk J. Sundt et a	ıl.					
		(Use several sheets if necessary)			1		l	roup art unit Not Yet Assigned			
			U.S	. PATENT I	OCUMENTS						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	CLA	SUB	CLASS	FILING DATE IF APPROPRIATE		
	AA	6,177,331 B1	01/23/01	Koga		438	424	1			
	AB	6,548,371 B2	04/15/03	Fujimaki		438	424	1			
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		ОТНЕ	R PRIOR A	RT (Including	Author, Title, Date, Pertine	ent Pages, Etc.)				
	AP	Cheung, N., Lecture notes (handout) EE 143, Lecture 15, University of California Berkely, 2000.									
	AQ	Clark, S., "Chemical Etching of Silicon Nitride (Si3N4) with Hot Phosphoric Acid (H3P6 Bold Technologies Technical Paper, 2000, pp. 1-6.									
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EXAMINE	R	** Met.co			DATE CONSIDER	ED					

* EXAMINER: